

AMENDMENTS TO THE SPECIFICATION

Please replace the paragraph on page 11, lines 4-19 with the following amended paragraph:

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Although, moveable elements that rotate are described herein, the present invention is in no way limited to in rotating devices. An example of a MEMS device **450** that uses anti-stiction members with a translating moveable element is depicted in FIG. **4B**. The device **450** generally comprises a substrate **451** and a moveable element **456**. Flexible anti-stiction members ~~[[460]]~~ **458** are interposable between the moveable element ~~[[406]]~~ **456** and the substrate **451**. In the device **450**, the moveable element **456** is configured to translate in direction substantially perpendicular to the substrate **451** as shown by the double-ended arrow. By way of example, the moveable element is retained between the substrate **451** and a cap **455**. The moveable element may move under the influence of a pneumatic force, e.g. provided by gas that enters the space between the substrate and the cap through a passage **453**. Alternatively, the moveable element **456** may move under the influence of an electrostatic or magnetic force. The anti-stiction members **460** may be interposed between the substrate **451** and the movable element **456** by exerting an actuating force on the moveable element **456** causing it to move away from the substrate. Once the moveable element moves far enough, the anti-stiction members **460** flex past the moveable element **456** and into position between the moveable element **456** and the substrate **451**.